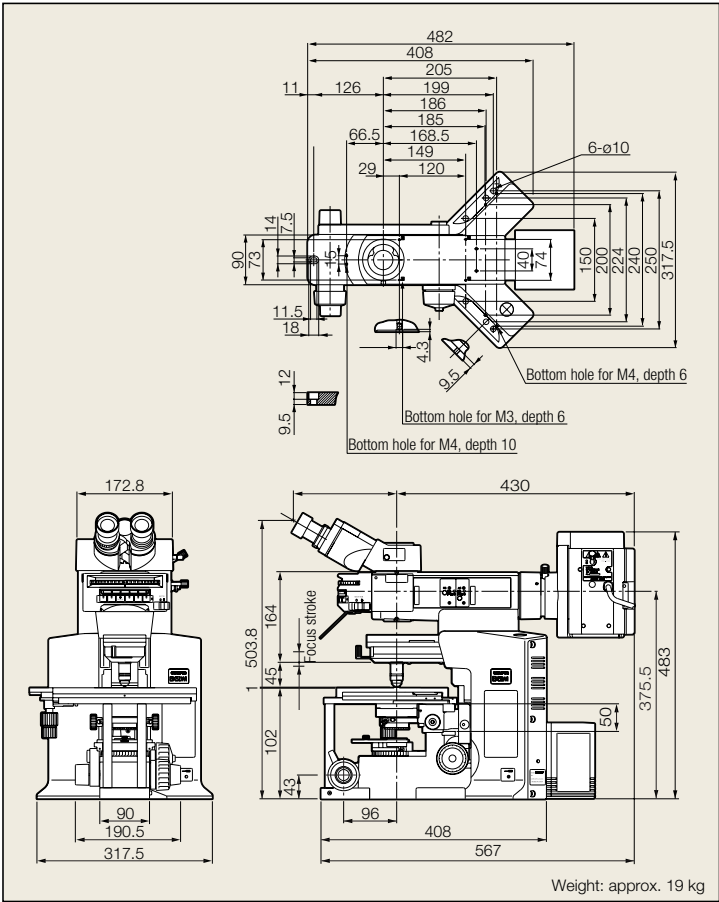
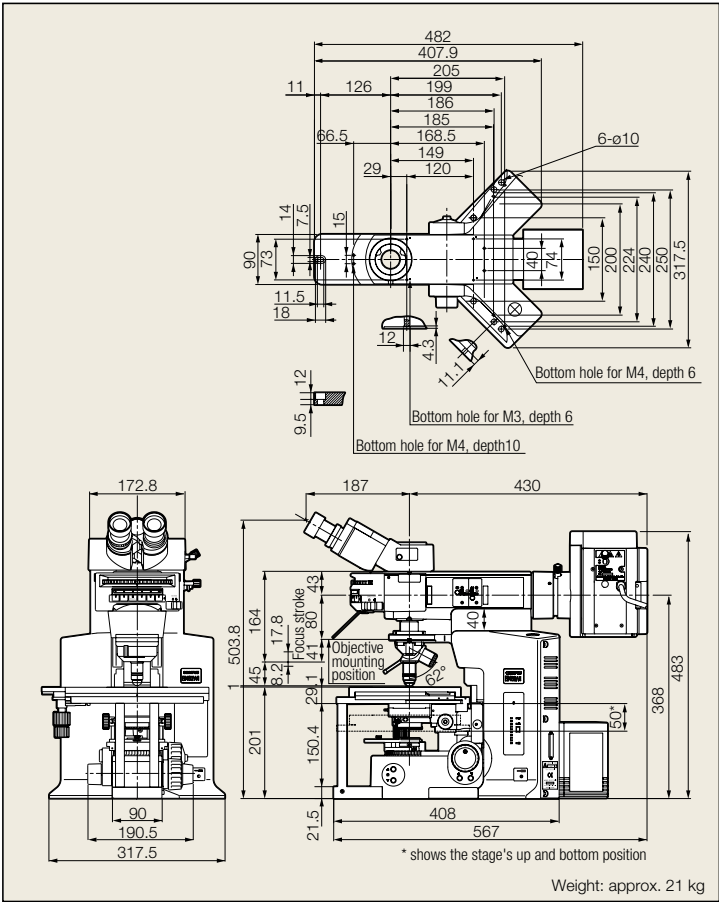


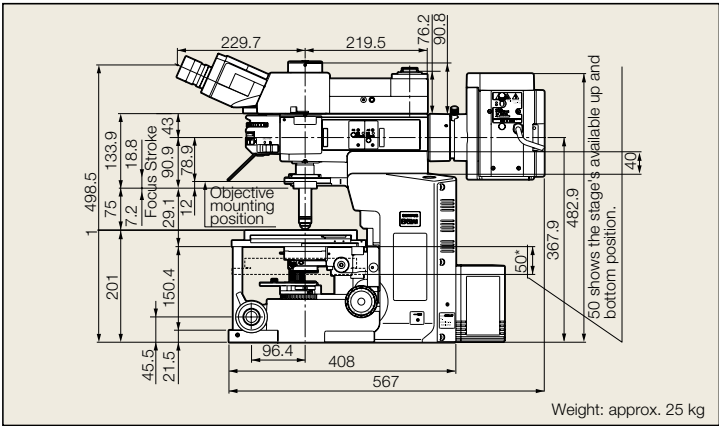
BX51WI dimensions (unit: mm)



BX61WI dimensions (unit: mm)



BX51+WI-DPMC dimensions (unit: mm)



• OLYMPUS CORPORATION has obtained the ISO9001/ISO14001.
• OLYMPUS CORPORATION has obtained the MD540624/ISO13485.
• Illumination devices for microscope have suggested lifetimes.
• Periodic inspections are required. Please visit our web site for details.
• Specifications and appearances are subject to change without any notice or obligation on the part of the manufacturer.



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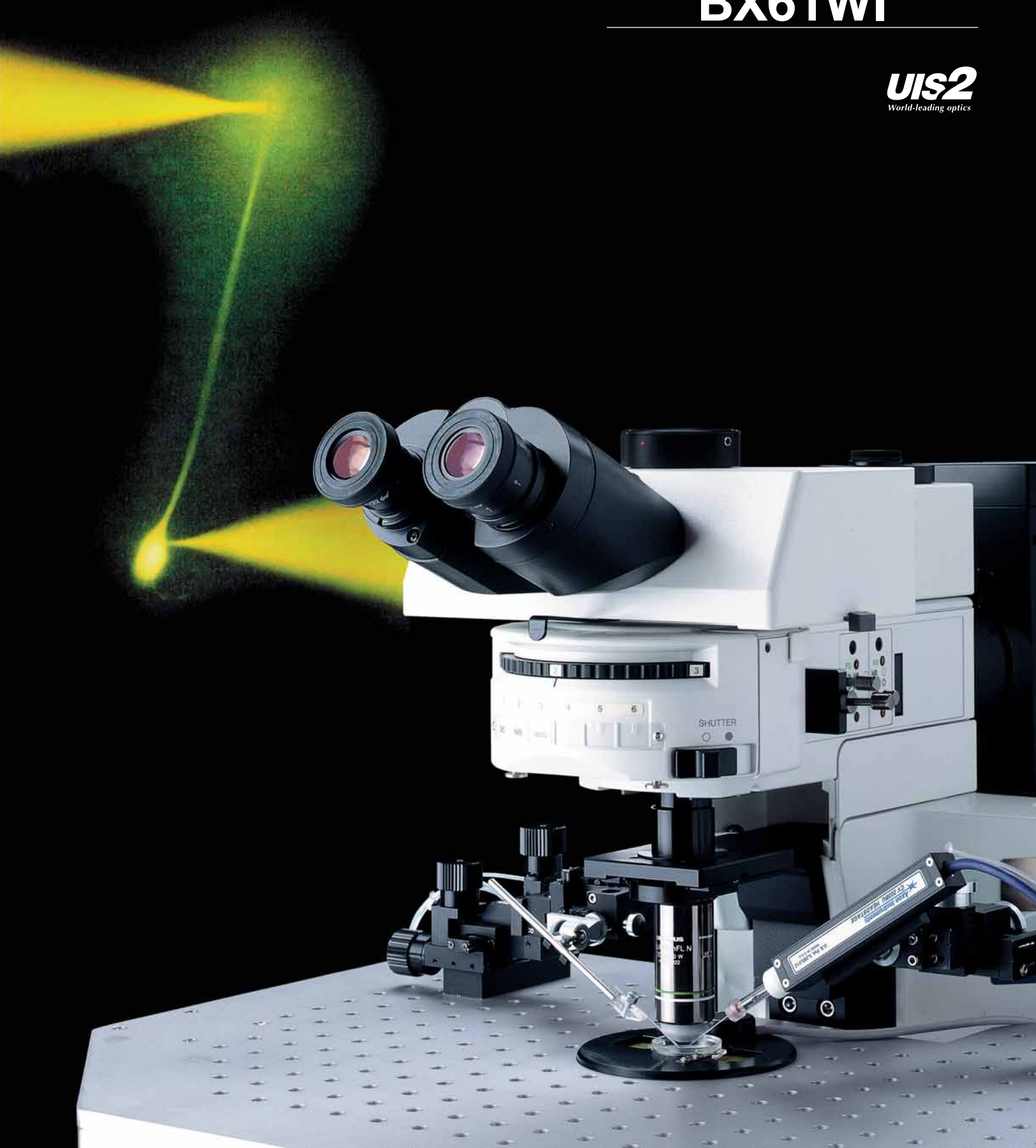
Fixed Stage Upright Microscope

BX51WI

Fixed Stage Upright Microscope with
Motorized Focusing

BX61WI

UIS2
World-leading optics

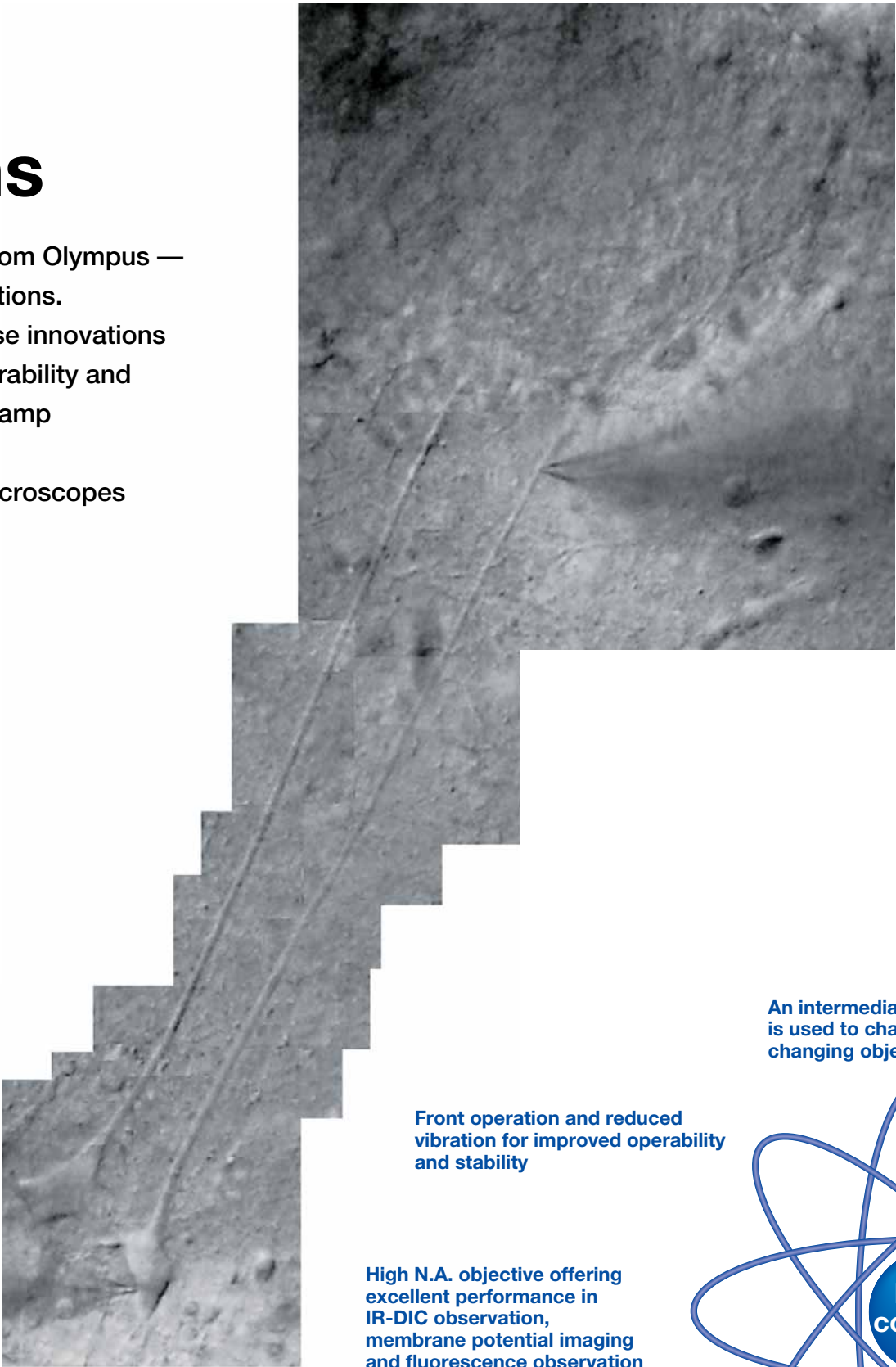


A dual commitment: Preventing vibration and protecting living cell specimens

One design theme was central to the development of the new fixed stage microscopes from Olympus — achieve an even higher standard of stability and reliability in electro-physiological applications. The result is a wide range of advanced new features to avoid and prevent vibration. These innovations include the introduction of a new observation method along with detailed analysis of operability and further refinements in image clarity. These improvements work together to make patch clamp operations smoother and more efficient than ever before. Combined with the traditional excellence of UIS2 optics, the new Olympus fixed stage microscopes define new levels of quality in both performance and ease of use.



BX51WI with Luigs & Neumann Accessories.



Front operation and reduced vibration for improved operability and stability

High N.A. objective offering excellent performance in IR-DIC observation, membrane potential imaging and fluorescence observation

Raising the objective and lowering the stage of the microscope enables easier experimentation on small animals

An intermediate magnification changer is used to change magnification without changing objectives

IR-DIC and IR oblique illumination condenser for deep-section observation

Full-system physiological confocal microscope, BX61WI with Z-axis motor is LSM ready

A special bridge stage and X Y mover are available for the microscope frame

Fluorescence macro objectives for membrane potential observation

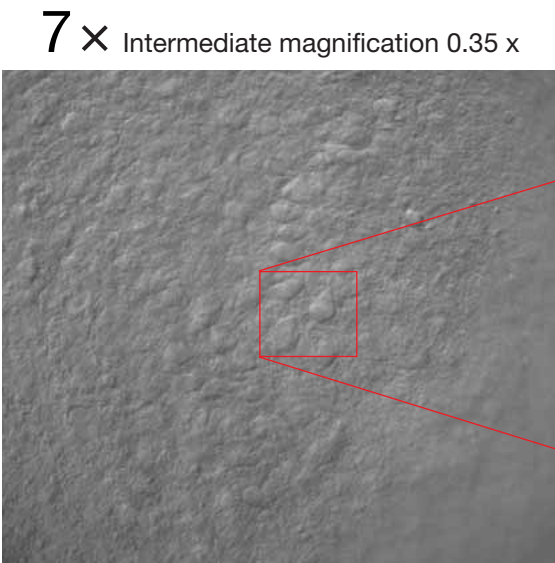
New concept

Interchanging low and high magnifications without changing objectives.

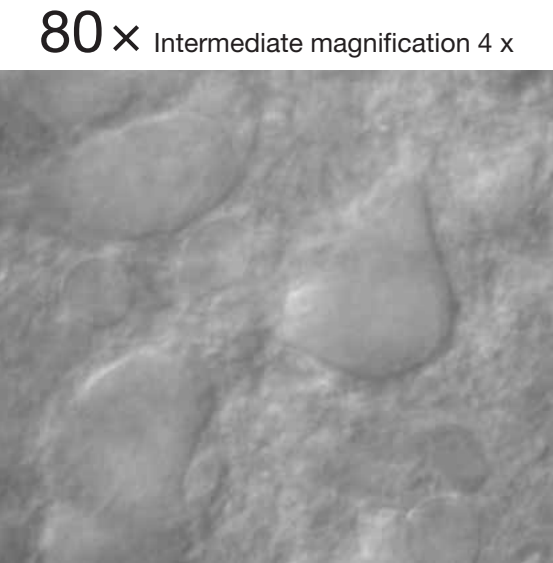
A new concept in vibration-free design.

A major concern for researchers conducting electro-physiology experiments is the vibration which occurs when switching objectives and the resulting interference this can cause to the specimens and adjacent equipment.

To solve this problem, Olympus introduces a new concept — the provision of an intermediate magnification changer in combination with the new High N.A. long working distance 20x objective that allows the user to switch between low and high magnifications without the need to switch objectives.



Examples using intermediate magnification changer WI-DPMC



IR-DIC observation, trigeminal motoneuron, Tomio Inoue Ph.D, Department of Oral Physiology, Showa University

New 20x objective (XLUMPLFLN20xW) N.A. 1.0; W.D.: 2.0 mm

The new 20x water immersion objective makes high-resolution observation possible with a wide range of intermediate magnification lenses. Since exchanges between low and high magnification are performed through the intermediate magnification changer, vibration is reduced to a minimum and the usual concern about collisions between objectives and patch clamp electrodes is eliminated.

Simultaneous fluorescence and IR-DIC observations

With the included 690 nm dichroic mirror in the WI-DPMC, fluorescence light is sent to the front port, and IR-DIC light is sent to the back port allowing two cameras to image simultaneously with no vibration introduced by light path selection.

Variable magnification dual port (WI-DPMC)

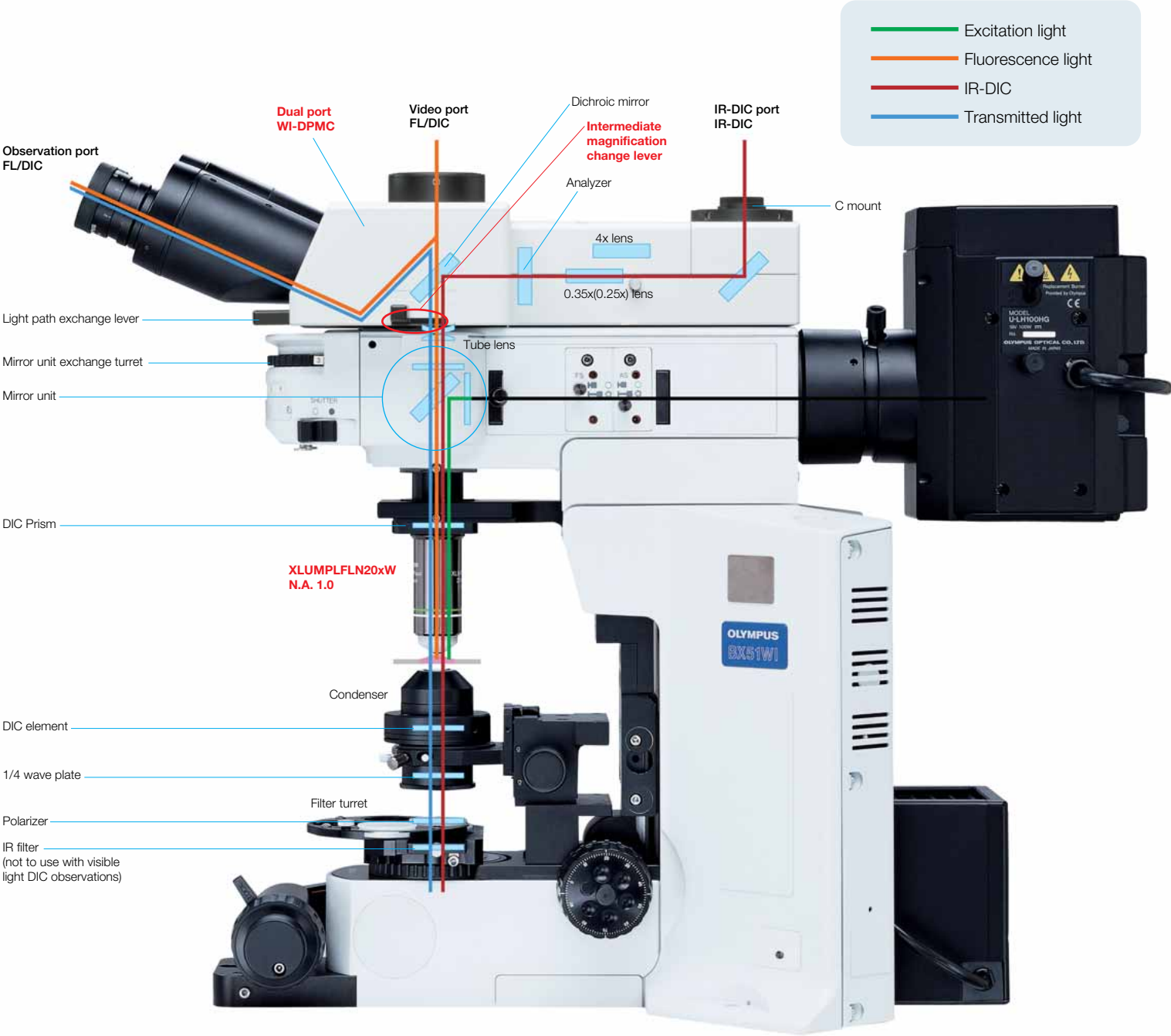
The WI-DPMC rear camera port includes a 2 position intermediate magnification selector. A high magnification 4x intermediate lens is included and a (0.25x or 0.35x) low magnification lens is optional. High or low magnification selection is via a single lever with no click-stops or detents allowing a specimen to be scanned and measured with minimal disturbance from vibration.

775 nm and 900 nm IR-DIC compatible.

*Available for 0.5x, 1x and 2x intermediate magnification lenses by special order.

Variable Click-stops

All click-stops, as when selecting between camera and observation modes, can be adjusted to the point of no click and thus no vibration.



Front operation with no shock and no noise. A new concept in experimental operation.

The new front operation system prevents interference in patch clamping work. The design concept is simple and allows frequently performed operations like focusing or filter exchange to be done easily at the front of the unit. Ample space is provided on both sides of the microscope frame and condenser, so the necessary manipulation equipment can be positioned close to the microscope.

1 Vibration-free shutter

The fluorescence shutter slides horizontally with no detents and no vibration.



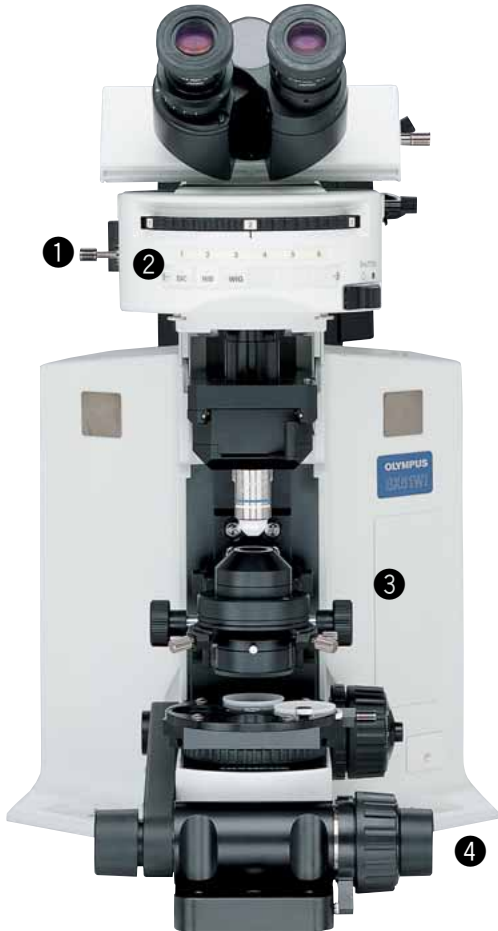
2 Mirror unit turret with adjustable click release

The click-stop on the 6 position turret can be released with a precision screwdriver.



3 Ample space around the condenser

Frame designed for ample space around the condenser, making it easy to adjust Nomarski DIC contrast, exchange filters, adjust the condenser's aperture stop and to easily switch between visible light, Nomarski DIC or IR-DIC.

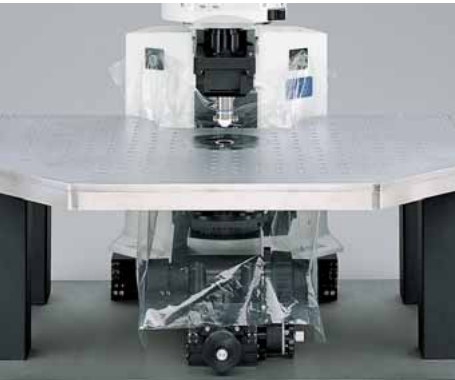


4 Front focus knobs close to the operator's hand

Fine focus control is located at the front on both sides of the microscope body. The knob on the right integrates both coarse and fine focus control.

5 Coarse focus lock lever

When engaged at the desired position, the objective can be raised with the coarse focus knob and then returned precisely to its original position.



6 A waterproofing sheet

A waterproofing sheet, attached by the supplied magnets, provides protection against liquid overflow and spills. The sheet is large enough to protect the frame, condenser and focusing mechanisms .



7 Remote power supply and hand switch

The remote TH4 power supply for transmitted light is designed with no cooling fan to minimize electrical noise. Features on/off and intensity controls. Can also be used with the optional TH4-HS hand switch providing light intensity and on/off control a maximal distance away from the Faraday cage.

Olympus offers a wide choice of nosepieces for different applications.



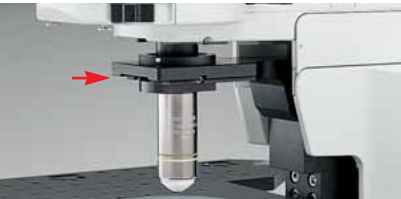
Swing nosepiece WI-SRE3

Unique slim, compact design and front-to-back swing motion permits objective changes without interfering with electrodes and micromanipulators. Objective positioning incorporates a vibration-free counterspring mechanism.



Slide nosepiece U-SLRE

This nosepiece is designed for the attachment of one large diameter, low magnification fluorescence objective (XLFLUOR 2x/340 or 4x/340) and one objective with normal (RMS) diameter threads. Nosepiece motion is a simple horizontal slide.



Single position nosepiece WI-SNPXLU2

Designed to accept the unique, large diameter XLUMPLFLN20xW objective.



RMS adapter WI-RMSAD

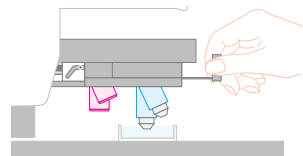
This adapter enables the attachment of an objective with RMS thread size to the WI-SNPXLU2.

The new swing-slide nosepiece prevents the intrusion of air bubbles



Swing-slide nosepiece WI-SSNP

This nosepiece features a new swing-slide motion, whereby the objective swings forward while being raised. As a result, the objective clears the walls of the perfusion chamber. This motion also prevents the trapping of air bubbles when the objective is lowered.



Special bridge stage and microscope mover for the BXWI

■ XY mover WI-XYM

The XY mover allows the movement of the microscope frame without moving either the specimen or electrodes. Especially useful for multiple patch-clamping experiments, the XY mover has convenient frontal controls.

■ Bridge stage WI-XYS

This stage is designed for small animal, in-vivo observations; Stage height can be lowered 50 mm by simply detaching the column spacers. Designed for use with the XY mover (WI-XYM), the stage platform is compact requiring minimal desk space. Stage top is pre-tapped and ferro-magnetic for flexibility in mounting manipulators. * Some manipulators cannot be used, due to the size of the stage.



Culture cell observation


IX-SVL2 general purpose platform stage. Mounts for left or right hand operation. Provides stable specimen X-Y movement.



BX51WI+IX-SVL2

New functionality and solutions to meet a wide variety of needs.

A powerful new concept.



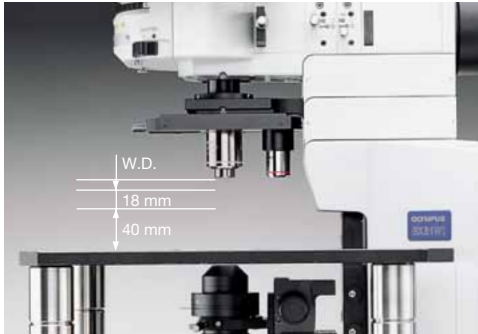
Experimenting with small animals

Raising the objective and lowering the stage to enable small animal experiments

The arm height raising kit (WI-ARMAD) provides an additional 40 mm of clearance and is mounted between the microscope frame and the reflected light illuminator. Small animal experiments usually do not require transmitted light thus allowing the removal of the substage condenser assembly. After removal, the stage may be lowered an additional 50 mm, providing a total clearance increase of 90 mm.



Normal configuration



40 mm more clearance via WI-ARMAD



Detaching the condenser assembly and lowering the stage by 50 mm provides maximal clearance



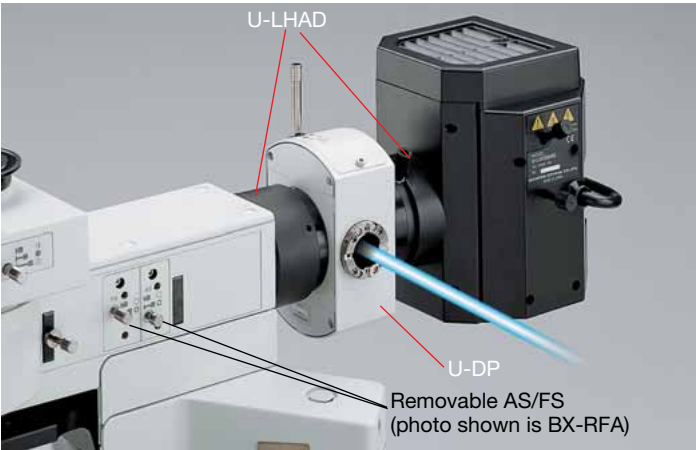
Photoactivation

A variety of convenient units to add light sources and control the light

Lamphouse adapter U-LHAD
This adapter allows the mounting of the dual port (U-DP) between the microscope frame and lamp housing.

Rectangular field stop U-RFSS
Designed for use with CCD cameras, prevents photobleaching of the specimen outside of the imaging area.

Pinhole unit BX-RFSPOT
Lighting the cell via a pinhole allows experimentation on reaction to light. Optional MELLES GRIOT's ø16 pinhole is used.



U-RFSS



BX-RFSPOT





Microinjection

BX Stage and adapter for injection experiments

The stage adapter WI-STAD is designed to allow the attachment of a traditional microscope right or left hand stage to the WI frame. The compact design of the BX2 stage (U-SVRB-4, or U-SVLB-4) reduces the distance between the specimen and the manipulator and creates a stable platform for injections.



Multiphoton Laser Scanning Microscope



BX61WI — Built in Z-axis focus

The BX61WI frame incorporates a precise Z-axis focus with 0.01 μm step size. Designed to incorporate the Olympus Fluoview scan unit and software, the BX61WI is ready for confocal z-stacks. Microscope frame includes programmable buttons for a wide variety of applications.

Optional Olympus Fluoview series — Multiphoton Laser Scanning Microscope FV1000MPE

Combining the BX61WI with the FV1000MPE allows you to craft an optimal system for the experiments you are performing, e.g. you can, in addition to multiphoton imaging, perform synchronization of laser light stimulation and patch clamp signals. Faithful to the principles of multiphoton excitation imaging, the FV1000MPE allows bright, high-resolution observation of areas deep within cells and tissues without damaging the specimen.

*FV1000MPE is a class 4 laser product.

Configuration example: BX61WI+FV1000MPE

Ultimate image clarity for electro-physiological experiments.

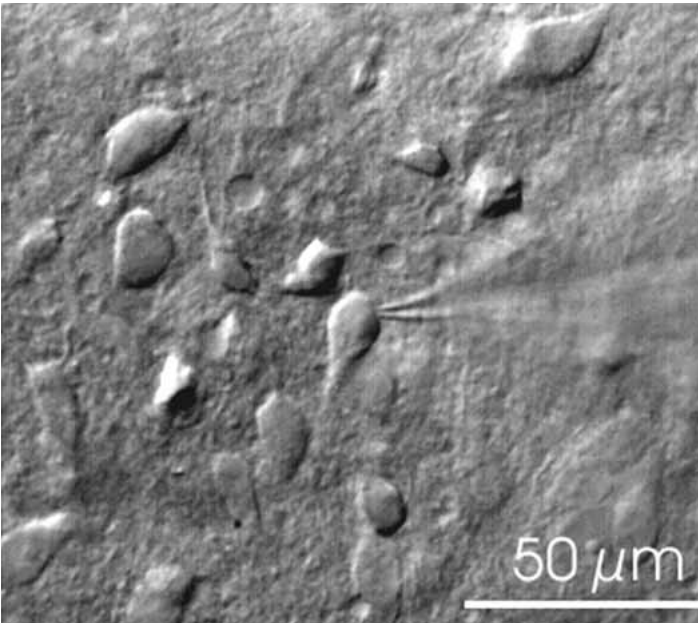
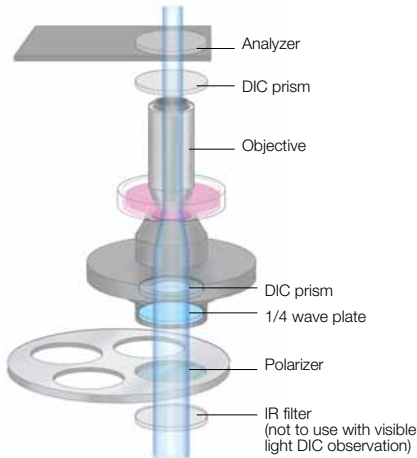
A new concept in live cell observation.

IR-DIC/ Nomarski DIC observation

IR-DIC Optimized Optics:
Designed for observations at 775 nm to 900 nm
Thanks to the precisely aberration-compensated IR-DIC optics covering from visible to near infrared light of 775 nm/900 nm wavelength, the clarity of images observed under near infrared light has been improved still further, allowing clear observation of even deep sections of brain slice.

- **Visible light DIC**
Allows operator high-resolution observation of the tissue surface.
- **775 nm IR-DIC**
In combination with an IR camera allows observation within the tissue slice. Optics are corrected for visible and IR wavelengths allowing fast switching between wavelengths with minimal refocusing.
- **900 nm Nomarski DIC**
Allows observation deeper into the tissue (requires special polarizer and analyzer optimized for 900 nm).

Senarmont compensation for Nomarski DIC observation
When using a Senarmont equipped condenser, all contrast adjustments are performed with the 1/4 wave plate below the condenser, thus eliminating the risk of bumping the stage, specimen, manipulators or nosepiece.



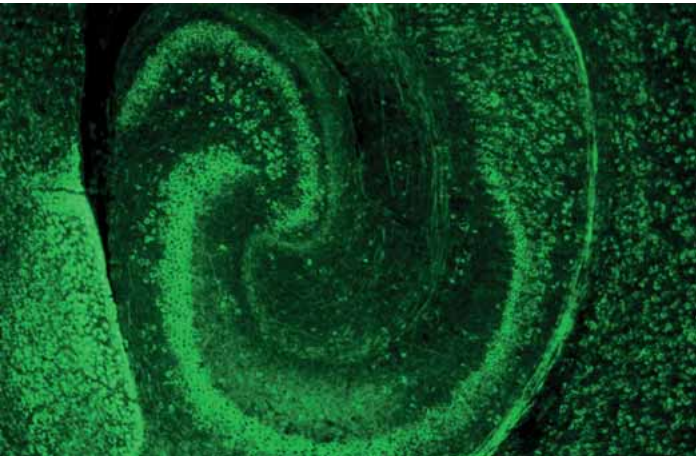
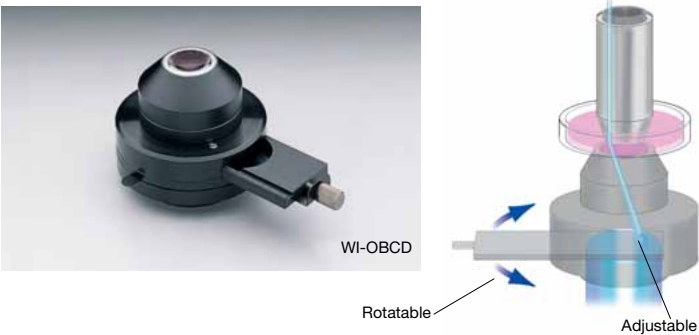
Nucleus of solitary tract from slice of rat medulla oblongata (thickness: 400 μm)
Prof. Fusao Kato
School of Medicine Physiology Dept.,
Jikei University
Kato & Shigetomi, J. Physiol.(2001), 530: 469-486

Universal condenser with DIC for improved contrast
Suitable for use in visible and 775 nm/900 nm near-infrared light, the U-UCD8 universal condenser is a high N.A., short working distance condenser offering improved contrast in nerve cell observations, for example.



Oblique illumination observation

Oblique observation optimizes contrast by changing the direction of the specimen shadow
Olympus has developed an oblique condenser (WI-OBOD) whose long working distance enables the angles of shadow to be altered through 360 degrees without moving the specimen. Requiring no additional accessories, oblique illumination is easy to set up and control. Plastic dishes (normally unsuitable for all types of DIC) are easy to image with oblique illumination. The oblique illumination slit aperture is variable in size and on a slider allowing quick changeover.



Transverse cryostat section through the hippocampus of a mouse at postnatal day 10 was stained with a mouse monoclonal anti-neurofilament-L (Chemicon, MAB1615).
An FITC-conjugated anti-mouse antibody was used for detection of NF-L.
Objective: XLFLUOR4x/340
Masaharu Ogawa, Ph.D
Laboratory for Cell Culture Development, Brain Science Institute, Riken

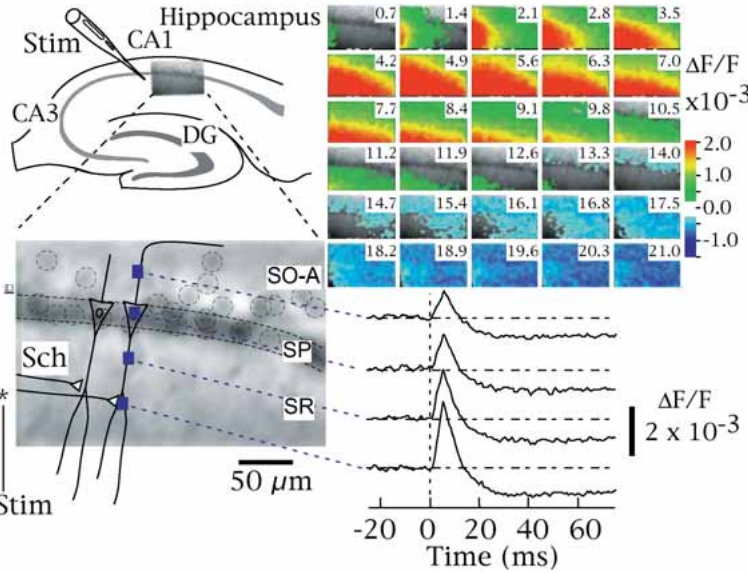
Fluorescence macro observation

2x and 4x Macro lenses with high numerical apertures provide fluorescence images
Designed for GFP imaging of large cells such as neurons
2x and 4x low magnification fluorescence objectives and a special GFP observation mirror unit are available. The objectives have a long working distance for maximum flexibility. An optional water immersion cap (XL-CAP) is also available to remove image aberrations caused by ripples on water surface of immersed specimens.



Observing changes in membrane potential

Measuring changes in membrane electric potential by using the XLUMPLFLN20xW objective with N.A. 1.0
The XLUMPLFLN20xW objective, with its high N.A., and 2.0 mm of working distance allows the measurement of cell membrane electric potential (as seen right). Also, the 4x macro objective (XLFLUOR4x/340) can be used to measure membrane potential at the tissue level. A water immersion cap (XL-CAP) can be attached to the macro 2x or 4x objectives to eliminate disturbances caused by water ripples.



Imaging of neuronal activity with voltage sensitive dye
Spread of neural activity in area CA1 of acute rat hippocampal slice (400 μm thick) in response to a single stimulation applied to Schaffer collateral pathway imaged (at frame rate of 0.7 ms/frame) with a fluorescent voltage sensitive dye (VSD; Di-4-ANEPPS). The fluorescent image (90x60 pixels) captured by a digital high-speed CCD camera (MICAM01, Brain Vision Inc.; with 20x super high N.A. objective and 0.5x adapter) is superimposed on the illustration of a hippocampal slice (upper left panel). The image is enlarged and shown on the illustration of pyramidal cells (solid line) (lower left panel). Each laminar of CA1 is shown as follows: SO-A, Stratum oriens-alveus; SP, Stratum pyramidale; SR, Stratum radiatum. The individual somas of cells were visible (indicated by dotted circle on the image) and were found along the stratum pyramidale. The changes in the fluorescence of VSD (optical signal) in accordance with the membrane potential change upon a stimulation (Stim) onto Schaffer collateral (Sch) were pseudo-color encoded and shown as consecutive images (upper right panel; number in each image shows time from the stimulation (ms)). The depolarizing signal (red) spread along Schaffer collateral, which was followed by a hyperpolarizing signal (blue) originated in stratum pyramidale. The time courses of optical signals in representative pixels are shown in lower right traces.

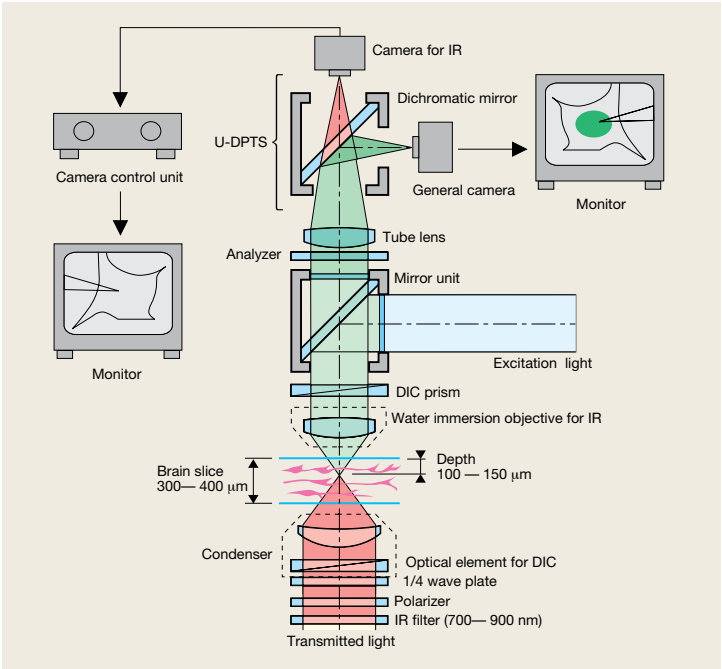
Takashi Tominaga Ph.D, Brain-Operative Device Lab., Brainway Group, Brain Science Institute, Riken
*The above data were obtained using a forerunner to the XLUMPLFLN20xW, but the XLUMPLFLN20xW can be used to perform the same operations.

Accessories

Multi double port tube U-DPTS

The U-DPTS accepts an optional dichroic mirror allowing the incoming to be split between visible and infrared and be observed simultaneously using two cameras.

* A fluorescence mirror unit is required.



Intermediate magnification changer U-ECA, U-CA

The U-ECA, which includes a 2x intermediate magnification position, allows quick magnification changes to a camera or observer without the need to change objectives. The U-CA includes a 4 position turret that allows rapid switching between a 1x, 1.25x, 1.6x and 2x positions. Both changers accept standard Olympus adapters for attaching a wide range of cameras.

* U-ECA and U-CA are not recommended for IR observation with the U-TR30 trinocular observation head.



C-mount video magnification change unit (IR-compliant) U-TVCAC

The U-TVCAC includes a 3-position turret with 1x, 2x, and 4x IR corrected positions. Includes a standard c-mount top port.



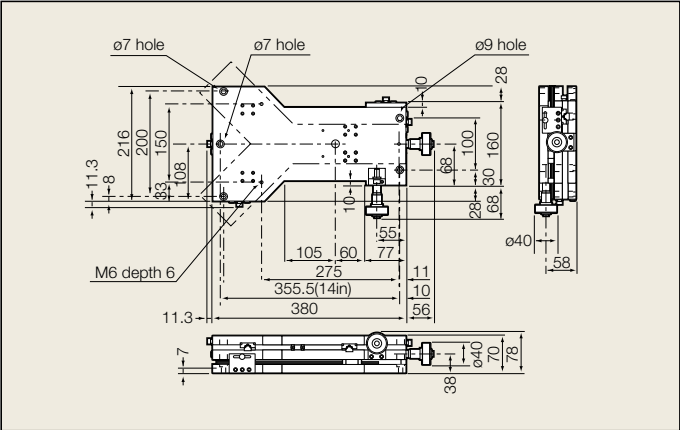
Objectives



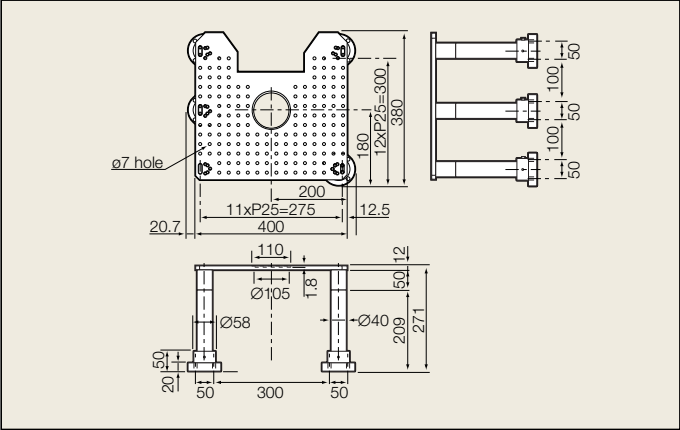
Objectives		N.A.	W.D. (mm)	Visible light	775 nm	900 nm
No cover objective	MPLN5x	0.10	20.0	○	—	—
Long working distance no cover water immersion objective	UMPLFLN10xW	0.30	3.5	○	○	○
	UMPLFLN20xW	0.50	3.5	○	○	○
	LUMPLFLN40xW	0.80	3.3	○	○	○
	LUMPLFLN60xW	1.00	2.0	○	○	○
	LUMFLN60xW	1.10	1.5	○	○	○
Long magnification fluorecence objective	XLFLUOR2x/340	0.14	21.0 (include 5 mm water)	○	○	—
	XLFLUOR4x/340	0.28	29.5 (include 5 mm water)	○	○	—
20x super high N.A. objective	XLUMPLFLN20xW	1.00	2.0	○	○	○

BX51WI/BX61WI specifications			
Optics		UIS2 optical system	
Material		Aluminum	
Illumination	BX51WI	Microscope body	Built-in Koehler illumination for transmitted light (F.N. 22), external light source, 12 V 100 W long life halogen bulb (pre-centered)(average lifetime: approximately 2,000 hours)
		Light source TH4	Light adjustment: DC2.5 V ~ 12.6 V (continuous adjustment) 8.4 A max. Power consumption: 150 W, dimensions: 75 (W) x 125 (H) x 200 (D) mm, weight 2 kg
	BX61WI	Microscope body	Built-in Koehler illumination for transmitted light (F.N. 22) 12 V 100 W long life halogen bulb (pre-centered) (average lifetime: approximately 2,000 hours) Light adjustment: less than DC2 V ~ 12 V (continuous adjustment) Brightness adjustment, light preset switch
		Light source BX-UCB	Power consumption: 200 W, dimensions: 125 (W) x 216 (H) x 310 (D) mm, weight 5 kg
Focus	BX51WI	Nosepiece focus by roller guide (rack & pinion) Stroke per rotation; fine: 0.1 mm coarse: 15 mm maximum stroke: 25 mm Coarse lower limit stopper mechanism, Torque adjustment mechanism for coarse focus	
	BX61WI	Motorized focusing using stepping motor and ball screw Nosepiece focus by cross roller guide Minimum graduation; fine: 1 μm (sensitivity 1 μm) resolution: 0.01 μm, maximum stage movement speed: 3 mm/s. Stroke per rotation; fine: 0.1 mm coarse: 1 mm Stroke: 25 mm, stage escape mechanism	
Nosepiece	WI-SRE3	Swing nosepiece	DIC prism: WI-DICTHRA, WI-DICT nosepiece arm: WI-NPA
	U-SLRE	Slide nosepiece	DIC prism: DIC observation is not available nosepiece arm: WI-NPA
	WI-SNPXLU2	Single position nosepiece	DIC prism: WI-DICTHRA, WI-DICT nosepiece arm: WI-NPA
	WI-SSNP	Swing-slide nosepiece	DIC prism: WI-DICTHRA, WI-DICT nosepiece arm: integrated
Fluorescent illuminator	BX-RFA	BX fluorescence illuminator, excitation balancer attachable, FS/AS detachable	
Observation tube	BX-URA2	BX reflected light illuminator	
	U-TR30-2	Trinocular, F.N.: 22, inclination angle: 30°, interpupillary distance: 50 mm — 76 mm Light path exchange; 3 steps ① BI: 100% ② BI: 20% video, photo: 80% ③ Video, photo: 100%	
	U-ETR-4	Erect image trinocular, F.N.: 22, inclination angle: 30°, interpupillary distance: 50 mm — 76 mm Light path exchange; 2 steps ① Binocular: 100% ② Video, photo: 100%	
	WI-DPMC	Double port magnification change unit, F.N.: 22, inclination angle: 24°, interpupillary distance: 50 mm — 76 mm, Light path exchange; 3 steps	
Stage	IX-SVL2	Mechanical stage, fixed to microscope body with WI-FSH, cross movement mechanism, X, Y axes handle torque adjustable (rack & pinion), movement range: 43 mm (Y) x 50 mm (X)	
	WI-XYX	Fixed on the anti-vibration table, cross movement mechanism (moved together with microscope body by WI-XYM)	
	U-SVL(R)B-4	Used together with WI-STAD, cross movement mechanism, X, Y axes handle torque adjustable (rack & pinion), movement range: 52 mm (Y) x 76 mm (X)	
Long working distance condenser	WI-UCD	Universal condenser, N.A.: 0.8, W.D.: 5.7 mm, with variable A.S. mechanism, turret: 4-position, four DIC prisms attachable	
	WI-DICD	DIC condenser, one DIC prism attachable	
	WI-OBOD	Oblique condenser, built-in variable oblique illumination stop	

WI-XYM dimensions (unit: mm)



WI-XYX dimensions (unit: mm)



WI-DPMC specifications

Optical light path exchange	3 steps	BI: 100% Front port 100% Simultaneous use of front (visible light) and back (near IR light) ports			
		Clicker ability adjustable			
Binocular observation tube	F.N. 22, inclination angle 24°, Interpupillary distance: 50 — 76 mm				
Front port	For fluorescent observation, F.N. 22, Simultaneous adjustment function with backport				
Back port	For IR observation (c mount adapter)				
Magnification change	Magnification changer lens magnification	Total magnification	N.A.	Projection magnification	
* custom made product (when combining with XLUMPLFLN20xW)	0.25x	5x	0.15	1/2 inch	
	0.35x	7x	0.22	2/3 inch	
	0.5x*	10x	0.4	2/3 inch	
	1x*	20x	0.95	2/3 inch	
	2x*	40x	0.95	2/3 inch	
	4x	80x	0.95	2/3 inch	
IR-DIC observation	Insert 775 nm analyzer or 900 nm analyzer into WI-DPMC				

WI-XYM, WI-XYX specifications

WI-XYM	Microscope	BX51WI, BX61WI
	X-Y stroke	25 mm (minimum graduation 10 μm)
	Maximum loading	294 N (30 kgf)
	Weight	Approx. 9.1 kg
	Applicable anti-vibration table	25 mm or 50 mm pitch with M5, M6 screw holes 1inch or 2 inch pitch with 1/4-20UNC screw holes Fixable
WI-XYX	Stage height	271 mm or 221 mm
	Manipulator setting	Fixable to ø7 mm or 25 mm pitch holes with M5 or M6 bolts and nuts
	Material	Iron (magnet can be used)
	Weight	Approx. 22.1 kg
	Applicable anti-vibration table	25 mm or 50 mm pitch with M5, M6 screw holes 1inch or 2 inch pitch with 1/4-20UNC screw holes

BX2WI SYSTEM DIAGRAM

